

Electronic Acknowledgement Receipt

EFS ID:	3655233
Application Number:	10689617
International Application Number:	
Confirmation Number:	4799
Title of Invention:	Method for cleaning plasma etching apparatus, method for plasma etching, and method for manufacturing semiconductor device
First Named Inventor/Applicant Name:	Satoru Okamoto
Customer Number:	26171
Filer:	Diana DiBerardino/Arlene Yates
Filer Authorized By:	Diana DiBerardino
Attorney Docket Number:	12732-170001
Receipt Date:	22-JUL-2008
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Application Type:	Utility under 35 USC 111(a)

Payment information:

Submitted with Payment	yes
Payment Type	Deposit Account
Payment was successfully received in RAM	\$510
RAM confirmation Number	7065
Deposit Account	061050
Authorized User	

The Director of the USPTO is hereby authorized to charge indicated fees and credit any overpayment as follows:

Charge any Additional Fees required under 37 C.F.R. Section 1.21 (Miscellaneous fees and charges)

File Listing:

Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)
1	Notice of Appeal Filed	12732170001NOA.pdf	68495	no	1
			284f75bc43f44b7ff21bb82c4c690c2eea65ea3f		

Warnings:**Information:**

2	Fee Worksheet (PTO-06)	fee-info.pdf	30061	no	2
			769380a49c92bc8e06d1c1dfb5959d2273810ce5		

Warnings:**Information:**

Total Files Size (in bytes):			98556
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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.